

Application Data Sheet

Application Information

Application Type:: Regular

Subject Matter:: Utility

Suggested Classification::

Suggested Group Art Unit::

CD-ROM or CD-R?:: None

Title:: Arrangement for Measuring Pressure on a Semiconductor Wafer and an Associated Method for Fabricating a Semiconductor Wafer

Request for Early Publication?:: No

Request for Non-Publication?:: Yes

Suggested Drawing Figure:: 53

Total Drawing Sheets:: 15

Small Entity:: No

Petition included?:: No

Secrecy Order in Parent Appl.?:: No

Applicant Information

Applicant Authority type:: Inventor

Primary Citizenship Country:: US

Status:: Full Capacity

Given Name:: Newell E.

Family Name:: Chiesl

City of Residence:: Colorado Springs

State if Province of Residence:: CO

Country of Residence:: USA
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Correspondence Information



24319

PATENT TRADEMARK OFFICE

Representative Information

Representative Customer Number:



24319

PATENT TRADEMARK OFFICE

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::

Assignee Information

Assignee name:: LSI Logic Corporation

Street of mailing address:: 1551 McCarthy Boulevard

City of mailing address:: Milpitas

State or Province of mailing address:: CA

Country of mailing address:: USA

Postal or Zip Code of mailing address:: 95035